



03500.013630.

2815

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MASAAKI IWANE ET AL. ) Examiner: Mr. Jose R. Diaz  
Application No.: 09/346,678 ) Group Art Unit: 2815  
Filed: July 2, 1999 )  
For: CRYSTAL GROWTH PROCESS, )  
SEMICONDUCTOR DEVICE, )  
AND ITS PRODUCTION )  
PROCESS ) May 3, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated February 3, 2004, please amend the  
above-identified application as follows.

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-  
1450 on

May 3, 2004

(Date of Deposit)

John A. Krause

(Name of Attorney for Applicant)

Signature

May 3, 2004

Date of Signature